Dedication

This research work is dedicated to:

My parents, brothers and sisters

My teachers

My friends

Acknowledgments

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مستخلص البحث

في هذا البحث تم إستخدام جهاز الترسيب بواسطة الأبخرة الكيميانية ذو الضغط المنخفض لتكوين أنابيب الكربون النانية. أستخدمت ستة عشر عينة من الحديد والكوبالت النانوية وتم تغييرتدفق معدل غاز الأستالين (10' 20' 30' و40 سنتميتر مكعب لكل دقيقة) ومعدل درجات الحرارة (450' 500' 500' و500 درجة مئوية). وقد حللت النتائج بواسطة جهاز المجهر الإلكتروني. وقد تبين أن أفضل صنع لأنابيب الكربون النانوية تمت عندما كان معدل الأستالين (20' 10' 20' 100' 500' 500' و500 درجة مئوية). وقد حللت النتائج بواسطة جهاز المجهر الإلكتروني. وقد تبين أن أفضل صنع لأنابيب الكربون النانوية تمت عندما كان معدل الأستالين 20 سنتميتر مكعب لكل دقيقة وعند درجات الحرارة (500' 500 درجة مئوية للحديد و500 درجة مئوية الأستالين 20 سنتميتر مكعب لكل دقيقة وعند درجات الحرارة 500' درجة مئوية للحديد و500 درجة مئوية الأستالين 20 سنتميتر مكعب لكل دقيقة وعند درجات الحرارة 500 درجة مئوية للحديد و500 درجة مئوية الأستالين 20 سنتميتر مكعب لكل دقيقة وعند درجات الحرارة 500 درجة مئوية للحديد و500 درجة مئوية للكوبات. وكذالك تم إيجاد قطر أنابيب الكربون النانوية بواسطة جهاز المجهر الإلكتروني بين 2نانومتر الي 30 للكوبات. وكذالك تم إيجاد قطر أنابيب الكربون النانوية بواسطة جهاز المجهر الإلكتروني بين 2نانومتر الي 30 الكوبات. وكذالك تم إيحاد قطر أنابيب الكربون النانوية بواسطة جهاز المجهر الإلكتروني بين 2نانومتر الي 30 الكوبات. وكذالك تم إيجاد قطر أنابيب الكربون النانوية بواسطة جهاز المجهر الإلكتروني بين 200 درجة مئوية الكوبات. أورز الفراكتان معانومتر الي 30 التومتر بالنسبة للكوبات. ثم قورنت النتائج بإستخدام طريقة التوميتر بالنسبة الكوبات. ثم قورنت النتائية بإستخدام طريقة التجزئة(الفراكتان).حيث بينت هذه الطريقة أن القطر يتراوح بين 1.62 ناتومتر و30 الحديد و30 الحديد و30 الحديد و30 التوية. والموبير الحدين و30 الحدين و30 الحديد و30 الحديد و30 الحديد و30 التورتي وقيم التجزئة تؤكد صحة النتائج.

Abstract

In this research, low pressure chemical vapor deposition system(LPCVD) was used to produced carbon nanotubes. It has been used for sixteen samples of iron Fe and cobalt Co according to actylene C_2H_2 rates change of (10, 20, 30, and 40sccm) and with temperature rates varied of (450°C, 650°C, 850°C, and 950°C) respectively. The morphology was studied by using scanning electron microscope (SEM).

It has been found carbon nanotubes CNTs was produced when acetylene rates was 20sccm at 950°C for iron and 650°C for cobalt. Also; it was found that the diameter of the tubes were 2~3 nm by using scanning electron microscope for both Fe and Co. The result obtained was compared with fractal analysis where the diameter ranges from 1.62 nm to 1.8 nm for both Fe and Co. This conformity between the ranges confirms the reality of the results.

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List of Notation and Abbreviation

| LPCVD | Low Pressure Chemical Vapor Deposition System | |
|--------|--|--|
| SEM | Scanning Electron Microscope | |
| SCCM | Standard Cubic Centimeter per Minutes | |
| CNTs | Carbon Nano-tubes | |
| SWCNTs | Single Wall Carbon nanotubes | |
| MWCNTs | Multi Wall Carbon nanotubes | |
| SAXS | Small Angle X-ray Scattering | |
| CRT | Cathode Ray Tube. | |
| Fe | Iron | |
| Со | Cobalt | |
| MF | Magnification Factor | |
| NSP | Number of Self-Similar | |
| D | Dimension | |
| Ν (ε) | Number of Box. | |
| Е | Number of Length | |
| BWs | Band Widths | |
| Units | | |
| Å | Angstrom = 10^{-10} m | |
| Nm | Nanometer = 10^{-9} m | |
| μm | Micrometer = 10^{-6} m | |